

Thin Film Systems



M-DEOS™
aTER™
BHDIII™
OMCTS
TMSA
DMDMOS
DMPS



Advanced Silicon
Precursors

Porogens

Silicon dopants

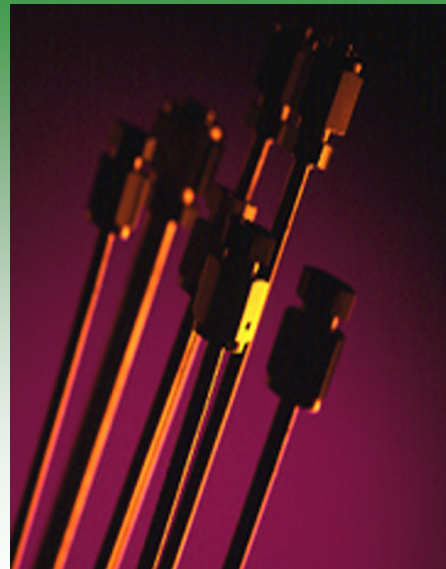
Chlorine sources

Adhesion promoters

GenStream®
Delivery System

TC2000™
Temperature
Controller

Ultra-High
Purity
Containers



TMB

TEB

TMP

TEPO

POCl₃

BBr₃

